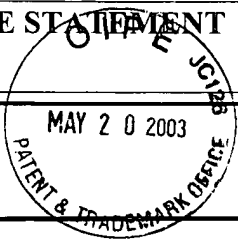


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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. AM-3245
In Re Application Of: <b>Hoiman Raymond HUNG et al.</b>			
Serial No. 09/276,376	Filing Date March 25, 1999	Examiner A. Olsen	Group Art Unit 1763
Title: <b>ENHANCEMENT OF SILICON OXIDE ETCH RATE AND NITRIDE SELECTIVITY USING HEXAFLUOROBUTADIENE OR OTHER HEAVY PERFLUOROCARBON</b>			
Address to: <b>Assistant Commissioner for Patents Washington, D.C. 20231</b>			
<b>37 CFR 1.97(b)</b>			
1. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.			
<b>37 CFR 1.97(c)</b>			
2. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:			
<input type="checkbox"/> the statement specified in 37 CFR 1.97(e);			
<b>OR</b>			
<input checked="" type="checkbox"/> the fee set forth in 37 CFR 1.17(p).			



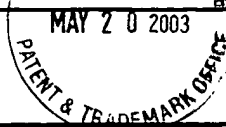
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**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
AM-3245

In Re Application: **Hoiman Raymond HUNG et al.**



Serial No.

09/276,376

Filing Date

March 25, 1999

Examiner

A. Olsen

Group Art Unit

1763

**ENHANCEMENT OF SILICON OXIDE ETCH RATE AND NITRIDE SELECTIVITY  
USING HEXAFLUOROBUTADIENE OR OTHER HEAVY PERFLUOROCARBON**

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(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☒ A check in the amount of **\$180.00** is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 50-0636 as described below. A duplicate copy of this sheet is enclosed.
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Dated: May 12, 2003

Charles S. Guenzer, Reg. No. 30,640

(650) 566-8040

Mailing Address:

Applied Materials, Inc.

Patent/Legal Department

P.O. Box 450A

Santa Clara, CA 95052

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U.S. Department of Commerce, Patent and Trademark Office					Docket No. <b>AM-3245</b>		
					Serial No.: <b>09/276,376</b>		
LIST OF RELEVANT ART CITED BY APPLICANT					Applicant: <b>Hoiman (Raymond) Hung et al.</b>		
(Use several sheets if necessary)					Filing Date: <b>March 25, 1999</b>		
					Group: <b>1763</b>		

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U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	6,117,786	09/12/00	Khajehnouri et al.	438	700		
AB	6,297,163	10/02/01	Zhu et al.	438	707		
AC							
AD							
AE							
AF							
AG							
AH							

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FOREIGN PATENT DOCUMENTS (Translation)								
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AL								
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.